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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/024,690	12/14/2001	Toshiaki Iwafuchi	0112857-306	2929	
29175	7590 07/27/2004		EXAMINER		
BELL, BOYD & LLOYD, LLC P. O. BOX 1135			EVERHART	EVERHART, CARIDAD	
CHICAGO, IL 60690-1135			ART UNIT	PAPER NUMBER	
,	,			2825	
			DATE MAILED: 07/27/2004		

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.	Applicant(s)				
		10/024,690	IWAFUCHI ET	IWAFUCHI ET AL.			
	Office Action Summary	Examiner	Art Unit				
		Caridad M. Everha	art 2825	K			
Period f	The MAILING DATE of this communic or Reply	eation appears on the cover	sheet with the correspondence	address			
THE - Exte after - If the - If NO - Failt Any	IORTENED STATUTORY PERIOD FO MAILING DATE OF THIS COMMUNIC insions of time may be available under the provisions of SIX (6) MONTHS from the mailing date of this commu e period for reply specified above is less than thirty (30) Depriod for reply is specified above, the maximum statu- ure to reply within the set or extended period for reply we reply received by the Office later than three months after led patent term adjustment. See 37 CFR 1.704(b).	CATION. f 37 CFR 1.136(a). In no event, however inication. days, a reply within the statutory minin utory period will apply and will expire St itll, by statute, cause the application to b	er, may a reply be timely filed num of thirty (30) days will be considered tir IX (6) MONTHS from the mailing date of this become ABANDONED (35 U.S.C. § 133).	mely. s communication.			
Status							
1)⊠	Responsive to communication(s) filed	10n 5-1.4-2004					
2a) <u></u> ☐	This action is FINAL . 21	o)⊠ This action is non-final					
3)□	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.						
Disposit	ion of Claims						
4)⊠)⊠ Claim(s) <u>1,3,4,9,11-31 and 33-74</u> is/are pending in the application.						
,—	4a) Of the above claim(s) is/are withdrawn from consideration.						
5)🖂	Claim(s) <u>12,25 and 36-53</u> is/are allow						
6)🖂	Claim(s) 1,3,4,9,15-22,26-31,33,54-6	0,62-66 and 68-73 is/are re	ected.				
7)⊠	Claim(s) 11,23,24,34,35,61,67 and 74	is/are objected to.					
8)□	Claim(s) are subject to restricti	on and/or election requirem	ient.				
Applicat	ion Papers						
9)[The specification is objected to by the	Examiner.					
	☐ The drawing(s) filed on is/are: a)☐ accepted or b)☐ objected to by the Examiner.						
	Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).						
	Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).						
11)	The oath or declaration is objected to	by the Examiner. Note the a	attached Office Action or form	PTO-152.			
Priority (under 35 U.S.C. § 119						
a)	Acknowledgment is made of a claim for All b) Some * c) None of: 1. Certified copies of the priority d 2. Certified copies of the priority d 3. Copies of the certified copies of application from the Internation.	ocuments have been receiv ocuments have been receiv f the priority documents hav al Bureau (PCT Rule 17.2(a	ved. ved in Application No ve been received in this Nation a)).	ıal Stage			
		·					
•	w.						
Attachmen	t(s) e of References Cited (PTO-892)	∧ □ -	storvious Summani (DTO 442)				
2) 🔲 Notic	e of Draftsperson's Patent Drawing Review (PT	O-948) P	nterview Summary (PTO-413) aper No(s)/Mail Date				
	mation Disclosure Statement(s) (PTO-1449 or P or No(s)/Mail Date		lotice of Informal Patent Application (P ther:	'TO-152)			

Applicant's arguments with respect to claims 1,3,4,9,15,-22,26-31,33, 54-60, 62-66, and 68-73 have been considered but are moot in view of the new ground(s) of rejection.

Applicant's translation filed 10-7-2003 of applicant's foreign priority document has been received. The rejection over the Buchwalter reference has been withdrawn.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in (1) an application for patent, published under section 122(b), by—another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

Claims 1,3,4,9,15-22,26-31,54-60,62-66, and 68-73 are rejected under 35 U.S.C. 102(e) as being anticipated by Kneissl et al (US 6,757,314B2).

Kneissel et al discloses release of a laser array structure from the insulating substrate and attachment to an intermediate support substrate, then attachment to a wafer and removal of the intermediate substrate(col. 2, lines 20-40). The structure is released from the sapphire substrate by laser liftoff by using an excimer laser which is adjusted to decompose a GaN layer which holds the device onto the sapphire substrate(col. 7, lines 57-67). The disclosure that the excimer laser is adjusted to decompose the GaN layer is interpreted to mean that the irradiation is selectively applied. The released device is transferred to an intermediate supporting substrate(col. 7, lines 43-55 and Fig. 11C),

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1105). Then the device is transferred to second substrate 1138 (col. 8, lines 60-67). There may be an adhesive layer of wax or epoxy holding the layer to the sapphire substrate (col. 7, lines 57-60). The excimer laser causes decomposition of the layer of the GaN by ablation, as is well known in the art, as removal of a layer by laser has the mechanism of ablation. The device is a light emitting device, a laser diode(abstract). There is a cleaning step (col. 8, lines 13-24) after the transfer to the holding layer.

Claim Rejections - 35 USC § 103

The text of those sections of Title 35, U.S. Code not included in this action can be found in a prior Office action.

Claim 14 is rejected under 35-U-S-C 103(a) as being unpatentable over Houston (US 3,783,297).

Houston discloses a silicone having indentations shaped in a form to receive a device(col. 6, lines 17-24 and Fig. 7).

Although Houston does not teach a pointed shape, it would have been obvious at the time of the invention to have formed the silicone indentations in the shape desired to receive a device of pointed shape.

Allowable Subject Matter

Claims 12,25,36-53, are allowed.

Claim11,23,24,34,35,61, 67,and 74 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

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Any inquiry concerning this communication or earlier communications from the examiner should be directed to Caridad M. Everhart whose telephone number is 571-272-1892. The examiner can normally be reached on Monday through Fridays 7:30-4:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Matthew S. Smith can be reached on 571-272-1907. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR.

Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

CARIDAD EVERHART PRIMARY EXAMINER

C. Everhart 7-26-2004